

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				<u>Complete if Known</u>	
				Application Number	10/718,981
				Filing Date	November 20, 2003
				First Named Inventor	Talson TAN et al.
				Art Unit	1746
				Examiner Name	N/A
Sheet	1	of	1	Attorney Docket number	Q175-US1

US PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS

Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published

Examiner Signature	/Robert Hodge/	Date Considered	03/08/2007
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Application Number	10/718,981
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